



Docket No.: 060188-0578

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 53080
	:	
Shinichi IMAI, et al.	:	Confirmation Number: 4939
	:	
Application No.: 10/619,191	:	Group Art Unit: 2125
	:	Allowed: June 01, 2007
Filed: July 15, 2003	:	Examiner: Maria N. Von Buhr
	:	
For: SYSTEM AND METHOD FOR MONITORING SEMICONDUCTOR PRODUCTION APPARATUS		

**REQUEST FOR ACKNOWLEDGEMENT OF THE CITED ART**

Mail Stop ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

We are in receipt of the Notice of Allowance dated June 01, 2007.

In reviewing the file, it is noted that we have not received acknowledgement of the Information Disclosure Statement and cited art filed June 14, 2007. Enclosed are copies of the Information Disclosure Statement, PTO-1449 and Acknowledgment Receipt of electronic filing.

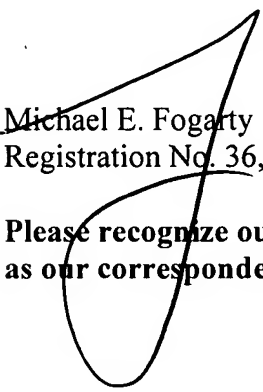
Applicant hereby respectfully requests that:

- (1) the appropriately acknowledged PTO-1449 be furnished to Applicant; and
- (2) the record be clarified to confirm that the cited art has been considered and made of record.

No.: 10/619,191

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

  
Michael E. Fogarty  
Registration No. 36,139

600 13<sup>th</sup> Street, N.W.  
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Phone: 202.756.8000 MEF:MWE  
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**Date: June 21, 2007**

**Please recognize our Customer No. 53080  
as our correspondence address.**

**Acknowledgement Receipt**

The USPTO has received your submission at **17:10:09** Eastern Time on **14-JUN-2007** by Deposit Account: 500417.

\$180/10

\$ ~~180~~ fee paid by e-Filer via *RAM* with Confirmation Number: 1878.








You have also pre-authorized the following payments from your USPTO Deposit Account:

Charge any Additional Fees required under 37 C.F.R. Section 1.16 and 1.17

**eFiled Application Information**

EFS ID	1874336
Application Number	10619191
Confirmation Number	4939
Title	SYSTEM AND METHOD FOR MONITORING SEMICONDUCTOR PRODUCTION APPARATUS
First Named Inventor	Shinichi Imai
Customer Number or Correspondence Address	20277
Filed By	Michael E. Fogarty/03328/Judith Harrison
Attorney Docket Number	60188-578
Filing Date	15-JUL-2003
Receipt Date	14-JUN-2007
Application Type	Utility

**Application Details**

Submitted Files	Page Count	Document Description	File Size	Warnings
060188-0578_ids.pdf	6	Information Disclosure Statement (IDS) Filed	107799 bytes	 WARNINGS
This is not an USPTO supplied IDS fillable form				
060188- 0578_reasons_for_rejection.pdf	14	NPL Documents	624382 bytes	 PASS
060188-0578_JP2002- 025981.pdf	17	Foreign Reference	991661 bytes	 PASS
060188-0578_JP2000- 252179.pdf	31	Foreign Reference	2059637 bytes	 PASS
060188-0578_JP10-135091.pdf	10	Foreign Reference	430088 bytes	 PASS
060188-0578_JP2000- 198051.pdf	10	Foreign Reference	613086 bytes	 PASS
060188-0578_JP2000- 252180.pdf	9	Foreign Reference	489495 bytes	 PASS

060188-0578\_JP2002-  
110493.pdf

8 Foreign Reference

415320  
bytes ♦ PASS

fee-info.pdf

2 Fee Worksheet (PTO-06)

8217 bytes ♦ PASS

This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.

#### New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

#### National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

#### New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.

#### *If you need help:*

- *Call the Patent Electronic Business Center at (866) 217-9197 (toll free) or e-mail [EBC@uspto.gov](mailto:EBC@uspto.gov) for specific questions about Patent e-Filing.*
- *Send general questions about USPTO programs to the [USPTO Contact Center \(UCC\)](#).*
- *If you experience technical difficulties or problems with this application, please report them via e-mail to [Electronic Business Support](#) or call 1 800-786-9199.*

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For: SYSTEM AND METHOD FOR MONITORING SEMICONDUCTOR PRODUCTION APPARATUS		

**INFORMATION DISCLOSURE STATEMENT**

Mail Stop IDS  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of a Final Rejection or Notice of Allowance, but before payment of the Issue Fee.

**REQUEST TO CONSIDER REFERENCES AFTER CLOSE OF PROSECUTION AND  
BEFORE PAYMENT OF ISSUE FEE**

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue there from. Please charge the processing fee under 1.17(p) of \$180.00 to Deposit Account .

CERTIFICATION PARAGRAPH

The undersigned certifies that each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement as described in 37 CFR 1.97(e)(1).

Each non-English language reference was cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the foreign search report or office action, together with an English language version thereof, is attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

  
Michael E. Fogarty  
Registration No. 36,139

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**Date: June 14, 2007**



SHEET 1 OF 1

INFORMATION DISCLOSURE  
CITATION IN AN  
APPLICATIONATTY. DOCKET NO.  
**060188-0578**SERIAL NO.  
**10/619,191**APPLICANT  
**Shinichi IMAI, et al.**FILING DATE  
**July 15, 2003**GROUP  
**2125**

(PTO-1449)

## U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		US			
		US			
		US			
		US			
		US			
		US			
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		US			
		US			

## FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes-Number 4-Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation Yes No
		JP 2002-025981	01/25/2002	Tokyo Electron Ltd	With English abstract	
		JP 2000-252179	09/14/2000	Hitachi Ltd	With English abstract	
		JP 10-135091	05/22/1998	Matsushita Electric Ind. Co. Ltd.	With English abstract	
		JP 2000-198051	07/18/2000	Matsushita Electric Ind. Co. Ltd.	With English abstract	
		JP 2000-252180	09/14/2000	Matsushita electric Ind. Co. Ltd.	With English abstract	
		JP 2002-110493	04/12/2002	Matsushita electric Ind. Co. Ltd.	With English abstract	

## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
		Notice of Reasons for Rejection dated May 15, 2007

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.